

S/N 09/208105



#2010  
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R. Shaden  
N.E.  
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: SAKAMOTO

Examiner: O. Nadav

Serial No.: 09/208105

Group Art Unit: 2811

Filed: November 25, 1998

Docket No.: 10233.81USW1

Title: SEMICONDUCTOR DEVICE AND A METHOD FOR MANUFACTURING THEREFORE

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By: 

Name: Chris Stordahl

**AMENDMENT UNDER RULE 116**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

In response to the official action, dated May 15, 2001, please amends this application as follow:

**In the Specification**

Please amend the specification to read as follow:

Please replace the paragraph beginning at page 8 line 5, with the following rewritten paragraph:

--resist layer 82 is formed above both the crystal--

Please replace the paragraph beginning at page 8 line 10, with the following rewritten paragraph:

--the silicon oxidation layer 27 is formed above the crystal--